EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L5	40	(wafer near etch$3) same (metal near mask$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:28
L6	8	(etch$3 same silicon) same (metal near (mask $3 with aluminum))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:38
L7	1343	(coil with (substrate or wafer)) same distance	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:51
L8	205	7 same induct$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:52
L9	69	8 and @pd<"20020814"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:52

4/5/08 1:06:58 PM
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